

S/N:
Docket : CS02-099
PRELINARY AMENDMENT

To: Commissioner of Patents
P.O. Box 1450
Alexandria, VA 22313-1450

5 From: William J. Stoffel
Reg no . 39,390
Customer no. 30,402
1735 Market St - Ste A
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Philadelphia, PA 19103

Subject:

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| Serial No. File date: Inventor: Tan et al. Title : Method For Dual Damascene Patterning With Single Exposure Using Tri-Tone Phase Shift Mask Group Art Unit: Examiner: |
|--|

15 file : CS02-099-preliminary amendment.doc

PRELIMINARY AMENDMENT

Dear Sir:

Please consider the following remarks:

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CERTIFICATE OF EXPRESS MAILING

I hereby certify that this correspondence is being deposited with the United States Postal Service as Express mail in an envelope addressed to: Commissioner of Patents, P.O. Box 1450, Alexandria, VA 22313-1450, on October 24, 2003.

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Signature/Date

W. J. Stoffel | 10/24/03
William J. Stoffel Reg. No. 39,390

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This Preliminary amendment has the following sections:

- **Amendments to the Specification** begin the next page of this paper
- **Remarks/Arguments** begin on the following page after the previous section